

## Application Data Sheet

### Application Information

Application number::

Filing Date::

Application Type::

Regular

Subject Matter::

Utility

Title ::

DEVICE FOR INSPECTING  
ELEMENT SUBSTRATES  
AND METHOD OF  
INSPECTION USING THIS  
DEVICE

Attorney Docket Number::

0756-7284

Total Drawing Sheets::

18

Small Entity?::

No

### Applicant Information

Applicant Authority Type::

Inventor

Primary Citizenship Country::

Japan

Given Name::

Masaaki

Middle Name::

Family Name::

HIROKI

Name Suffix::

City of Residence::

Atsugi-shi

State or Province of Residence::

Kanagawa-ken

Country of Residence::

Japan

Street of mailing address:: c/o Semiconductor Energy  
Laboratory Co., Ltd., 398,  
Hase  
City of mailing address:: Atsugi-shi  
State or Province of mailing address:: Kanagawa-ken  
Country of mailing address:: Japan  
Postal or Zip Code of mailing address:: 243-0036

## Correspondence Information

Correspondence Customer Number :: 31780  
E-Mail address:: erobinson@riplo.com

## Representative Information

Representative Customer Number:: 31780

## Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	Divisional	09/866,651	05/30/2001

## Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2000-168143	06/05/2000	Yes

## Assignee Information

Assignee name::	Semiconductor Energy Laboratory Co., Ltd.
Street of mailing address::	398 Hase
City of mailing address::	Atsugi-shi
State or Province of mailing address::	Kangawa-ken
Country of mailing address::	Japan
Postal or Zip Code of mailing address::	243-0036